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Declarations under Rule 4.17:

— of inventorship (Rule 4.17(iv))

Published:

— with international search report (Art. 21(3))

(84) Designated States (unless otherwise indicated, for every kind of regional protection available): ARIPO (BW, GH, GM, KE, LR, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AL, AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HR, HU, IE, IS, IT, LT, LU,

(57) Abstract: Device for holding a silicon melt comprising a crucible (1; 1a; 1b), which partly surrounds an inner chamber (2) for holding the melt, with a base (3; 3a) and at least one side wall (4; 4b) made of a base material, whereby the crucible (1; 1a; 1b) comprises at least one equalising means (5) for equalising mechanical thermal stresses.